

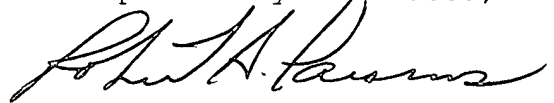
1 INFORMATION DISCLOSURE STATEMENT

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3 TO THE COMMISSIONER OF PATENTS AND TRADEMARKS:

4
5 Your applicant, Nicholas Andros, inventor of METHODS OF
6 MANUFACTURING POLISHING SUBSTRATES, application for which is
7 submitted concurrently herewith (RAP Docket No. 3547-A4) as a
8 duty of candor and good faith toward the United States Patent
9 and Trademark Office, by and through the undersigned Attorney,
10 hereby submits his information disclosure statement in
11 compliance with 37 C.F.R. 1.56.
12

13 Applicant is aware of references listed in the attached
14 Form PTO 1440. Copies of two (2) cited references are enclosed.
15

16 Respectfully submitted,

17 

18 Robert A. Parsons

19 Attorney for Applicant

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21 2/13/02

22 DATE

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JC997 U.S. PTO
10/075475
02/13/02

42
7-27-02

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

Docket Number

3547-A4

Application Number

Applicant

ANDROS

Filing Date

Group Art Unit

J4997 U.S. PTO
10/075475

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,311,634 6,022,268	17MAY94 08FEB00	ANDROS ROBERTS et al.			

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Dates, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the application.